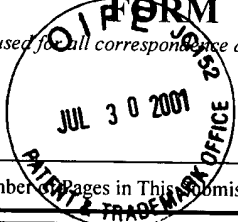


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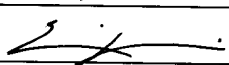
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TRANSMITTAL FORM (to be used for all correspondence after initial filing) 		Application Number	09/640,519
		Filing Date	August 17, 2000
		First Named Inventor	Hiroaki NAKAOKA et al.
		Group Art Unit	2818
		Examiner Name	D. Vu
Total Number of Pages in This Submission		Attorney Docket Number	740819-408

ENCLOSURES (check all that apply)

<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input checked="" type="checkbox"/> Amendment / Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Assignment Papers (for an Application) <input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s) _____	<input type="checkbox"/> After Allowance Communication to Group
Remarks		The Amendment previously filed on July 16, 2001 included a check for \$890.00 (payment for a third-month extension of time)

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

Firm Or Individual name	<u>Eric J. Robinson</u> Nixon Peabody LLP 8180 Greensboro Drive Suite 800 McLean, VA 22012
Signature	
Date	7-30-01

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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on this date: 		
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Docket No. 740819-408

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In re PATENT application of:)
Hiroaki NAKAOKA et al.) Examiner: D. Vu
Serial No. 09/640,519) Art Unit: 2818
Filed: August 17, 2000)
For: METHOD OF FABRICATING)
SEMICONDUCTOR DEVICE)

7/13
S. Mackley
8-3-01

AMENDMENT AND RESPONSE TO
NOTICE OF NON-COMPLIANT AMENDMENT (37 C.F.R. 1.121)

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Notice of Non-Compliant Amendment dated July 24, 2001, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claims 1, 2 and 8 as follows. Attached hereto is a marked-up copy of the amended claims.

1. (Amended) A method of fabricating a semiconductor device, the method comprising the steps of:
- (a) forming a silicon oxynitride film on a silicon substrate;
 - (b) performing a heat treatment while keeping a surface of the silicon oxynitride film in contact with a gas containing nitrogen to introduce at least nitrogen into the silicon oxynitride film;
 - (c) after step (b), forming a semiconductor film containing an impurity of first conductivity type on the silicon oxynitride film;